Docket No.: H0498.70130US01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Tao Deng et al.

Serial No.:

10/763,819

Confirmation No.:

5026

Filed:

January 23, 2004

For:

FABRICATION OF METALLIC MICROSTRUCTURES VIA

EXPOSURE OF PHOTOSENSITIVE COMPOSITION

Examiner:

K. Duda

Art Unit:

1756

Certificate of Mailing Under 37 CFR 1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

1/20/88

TRANSMITTAL LETTER

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Enclosed are the following items for filing in connection with the above-referenced Patent Application:

- 1. Amendment; and
- 2. Return Receipt Postcard.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 23/2825, under Docket No.

H0498.70130US01. A duplicate copy of this paper is enclosed.

Dated: January 36, 2008

Respectfully submitte

Timothy J. Oyer, Ph.D. Registration No.: 36,628

WOLF, GREENFIELD & SACKS, P.C.

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108

Dated:

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated December 12, 2007, please amend the aboveidentified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.